

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

Agilent No. 10972039-2
R&A No. 5000-0029



August 22, 2000
8/22/00 *Marilyn B. McKenna*
Date Signature

9/8/00
#6/Amend
A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Reid A. BRENNEN et al.

Group Art Unit: 1756

Serial No.: 09/233,694

Examiner: C. Young

Filing Date: January 19, 1999

Title: METHOD FOR PRODUCING HIGH-SURFACE
AREA TEXTURING OF A SUBSTRATE,
SUBSTRATES PREPARED THEREBY AND
MASKS FOR USE THEREIN

RECEIVED
AUG 31 2000
TO 1100 MAIL ROOM

AMENDMENT UNDER 37 C.F.R. §1.111

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This is in response to an Office Action on the merits concerning the patent application identified above, mailed from the PTO on May 22, 2000. Reconsideration of the application in view of the following amendments and remarks is respectfully requested.

AMENDMENTS

IN THE CLAIMS:

Please amend claims 23 and 24 as follows:

23. (Amended) A high-surface area textured substrate prepared by a process comprising subtracting a material from, adding material to, or both subtracting material from and adding